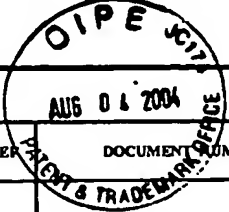


INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional) EM002-US		Application Number 10/731,021
Applicant(s) Takashige Terakawa et al.		
Filing Date December 10, 2003	Group Art Unit 2817	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
cm		06-233521	08/19/94	JAPAN			ABS	
		08-265085	10/11/96	JAPAN			ABS	
cm		01-316012	12/20/89	JAPAN			ABS	
cm		51-91642	08/05/76	JAPAN				✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

		Japanese Office Action dated May 6, 2004, with partial English translation.

EXAMINER Sengsook Han	DATE CONSIDERED 1/28/05
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EM002-US

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Takashige Terakawa, et al.

Filing Date 12/10/03
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Group Art Unit 2817
~~Not Yet Assigned~~

[illegible][illegible]

Sensornik Han

1/26/05

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